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E UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9850

Shinji KAJITA et al.

Attorney Docket No. 2004_0120A

Serial No. 10/765,182

Group Art Unit 1746

Filed January 28, 2004

Examiner Mark J. Heckert

APPARATUS FOR AND METHOD OF PROCESSING SUBSTRATE

Mail Stop: AF

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 26, 2007, please amend the abovereferenced U.S. patent application as follows:

> RESPONSE UNDER 37.CFR 1.116 **EXPEDITED PROCEDURE**

EXAMINING GROUP